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	Application No.	Applicant(s)	
Notice of Allowability	10/066,849	LEE ET AL.	
	Examiner	Art Unit	
	John Ruggles	1756	
The MAILING DATE of this communication ap All claims being allowable, PROSECUTION ON THE MERITS I herewith (or previously mailed), a Notice of Allowance (PTOL-8 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT of the Office or upon petition by the applicant. See 37 CFR 1.3	S (OR REMAINS) CLOSED in 5) or other appropriate commu RIGHTS. This application is s	n this application. If not inclu unication will be mailed in du	uded ue course. <b>THIS</b>
1. $igspace$ This communication is responsive to <u>the amendment file</u>	<u>d 5/11/05</u> .		
2. The allowed claim(s) is/are <u>1,2 and 4-14</u> .			
3. $\boxtimes$ The drawings filed on <u>04 February 2002</u> are accepted by	the Examiner.		
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority <ul> <li>a)  All b)  Some* c) None of the:</li> <li>1.  Certified copies of the priority documents hat</li> <li>2.  Certified copies of the priority documents hat</li> <li>3.  Copies of the certified copies of the priority of International Bureau (PCT Rule 17.2(a)).</li> </ul> </li> <li>* Certified copies not received:</li> </ul>	ve been received. ve been received in Applicatio documents have been received	n No d in this national stage appli	
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the	requirements
<ol> <li>A SUBSTITUTE OATH OR DECLARATION must be sub INFORMAL PATENT APPLICATION (PTO-152) which g</li> </ol>			r NOTICE OF
6. CORRECTED DRAWINGS ( as "replacement sheets") m	ust be submitted.		
(a) ☐ including changes required by the Notice of Draftspe	<del>-</del>	v ( PTO-948) attached	
1)  hereto or 2) to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examine Paper No./Mail Date	er's Amendment / Comment or	in the Office action of	
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in			the back) of
7. DEPOSIT OF and/or INFORMATION about the der attached Examiner's comment regarding REQUIREMEN	posit of BIOLOGICAL MATE T FOR THE DEPOSIT OF BIO	ERIAL must be submitted DLOGICAL MATERIAL.	I. Note the
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. ☐ Notice of Int	formal Patent Application (F	PTO-152)
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948	6. 🗌 Interview St	ummary (PTO-413),	·
3. Information Disclosure Statements (PTO-1449 or PTO/SE		Mail Date Amendment/Comment	
Paper No./Mail Date  4.  Examiner's Comment Regarding Requirement for Deposit	t 8. ⊠ Examiner's	Statement of Reasons for A	Allowance
of Biological Material	9.	- Orhufugg	bs

John Ruggles Examiner, Art Unit 1756 571-272-1390

Application/Control Number: 10/066,849

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## **EXAMINER'S AMENDMENT**

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Michael Hull on 7/8/05.

The application has been amended as follows:

## IN THE SPECIFICATION:

At page 1 line 12, change "limit results" to --limited results--.

At page 1 line 18, change "self-align" to --self-aligned--.

At page 4 line 17, change "of semiconductor device" to --of a semiconductor device--.

At page 5 line 22, change "using dual damascene process" to --using <u>a</u> dual damascene process--.

At page 7 line 26, change "a the void" to --a the void--.

At page 9 line 7, change "via hole 39 (see Figs. 3C-3E)" to --via hole 39 (see Figs. <del>3C</del> 3B-3E)--.

At page 9 line 13, change "may be maximized the etch profile" to --may be maximized so that the etched profile--

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IN THE CLAIMS:

At claim 1 line 17, delete the phrase "at least" before "partially covering the via hole".

At claim 7 lines 3-4, change "either by plasma" to --by either by plasma--.

Allowable Subject Matter

Claims 1-2 and 4-14 are allowed.

The following is an examiner's statement of reasons for allowance: the prior art does not clearly teach all the specific limitations of the instant claims as currently amended and especially does not show forming a fourth interlayer insulating layer on the portion of a second etching stop layer disposed around the inlet of a via hole and an exposed portion of a third interlayer insulating layer and partially covering the via hole (claim 1), wherein a void is formed in the fourth interlayer insulating layer (claim 6). For at least this reason, claims 1 and 6 are allowable over the prior art. Claims 2 and 4-14 depend on claim 1 are therefore allowable over the prior art.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to John Ruggles whose telephone number is 571-272-1390. The examiner can normally be reached on Monday-Thursday and alternate Fridays.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Mark Huff can be reached on 571-272-1385. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

John Ruggles

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MARK F. HUFF
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 1700